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VACUUM TUBES

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VACUUM TUBES

KARL R. SPANGENBERG

PROFESSOR OF ELECTRICAL ENGINEERING

STANFORD UNIVERSITY

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VACUUM TUBES

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TO MY COLLEAGUES AND STUDENTS

PREFACE

This book is the outgrowth of a course in vacuum-tube design given for many years at Stanford University to senior and graduate students in electrical engineering and physics. It is concerned with the determination of vacuum-tube characteristics in terms of the electron action within the tube. The book attempts to bridge the gap between the physical laws that lie behind the electron behavior and the external characteristics of the tubes themselves.

It is hoped that the point of view taken will be acceptable to both physicists and engineers. The development of the physical laws involved is indicated, after which emphasis is placed upon their description and utilization. Although this book cannot pretend to give much design information, the attempt has been to include enough of the basic relations, physical data, and significant references to make it a useful reference source to vacuum experimenters and tube designers.

Vacuum tubes may seem a rather special subject to which to restrict the material in a book. Actually this is not so. In preparing the book so much material was collected that the contents had to be restricted to first-order effects. It is felt that although engineers and physicists working with vacuum tubes are primarily concerned with the utilization of already developed tubes, the successful application of these tubes is greatly enhanced by a knowledge of their limitations and an understanding of the origin of their characteristics. This is particularly true since there are many occasions when it is desired to use tubes under conditions different from those specified by the manufacturer. Under these conditions it is imperative to know how far one may depart from recommended operating conditions without exceeding some design limitation of the tube. This, in turn, requires a knowledge of how the tube operates.

Circuits and tube applications are so completely covered in the textbook and periodical literature that no effort has been made to include information on these subjects. Only in the case of ultra-high-frequency tubes where the tube cannot be completely separated from the circuit have circuit considerations been included.

The author is indebted to many people for assistance rendered in the preparation of this book. He is particularly indebted to Dr. F. E. Ter-

man, dean of the Stanford School of Engineering, who was a constant source of inspiration and encouragement, and who made many valuable suggestions and gave much direct assistance in checking the work. The author is also indebted to Prof. Paul Kirkpatrick, head of the Physics Department at Stanford, for suggestions on the material of Chaps. 3 to 6 and 9; to Prof. L. Marton for suggestions on the material of Chaps. 13 to 15 and 20; and to C. V. Litton for much information and suggestions relative to Chap. 21. He is indebted to Evelyn G. Sarson, who typed a large part of the manuscript in its final form. O. O. Pardee and Will Harman assisted in the correction of the entire work. Lastly, the author is more than a little indebted to his wife, who personally typed much of the manuscript and was a source of constant assistance.

KARL R. SPANGENBERG

PALO ALTO, CALIF.
January, 1948

CONTENTS

	PAGE
PREFACE.	vii
CHAPTER 1—INTRODUCTION	1
1.1 Devices Using Electron Tubes	1
Radio Receivers—Radio Transmitters—Long-distance Wire Tele- phones—Television Systems—Measurement Devices—Industrial Con- trol	
1.2 Functions of Vacuum Tubes.	2
Rectification—Amplification—Oscillation—Frequency Conversion— Modulation — Detection — Light-image Production — Photoelectric Action	
CHAPTER 2—BASIC TUBE TYPES	5
2.1 Vacuum Diode.	5
2.2 Vacuum Triode	6
2.3 Screen-grid Tube.	7
2.4 Pentode.	8
2.5 Beam-power Tube	9
2.6 Cathode-ray Tubes.	12
2.7 Klystron	13
2.8 Magnetron	15
2.9 Phototubes	17
CHAPTER 3—ELECTRONS AND IONS	19
3.1 The Electron	19
3.2 The Proton	19
3.3 Other Fundamental Particles.	20
3.4 Atoms and Molecules.	20
3.5 Ions	22
CHAPTER 4—ELECTRONIC EMISSION	23
4.1 Theory of Thermionic Emission	24
Work Function—The Emission Equation—Types of Emitter	
4.2 Emission of Pure Metals	35
Tungsten—Tantalum	
4.3 Atomic-film Emitters	39
4.4 Oxide Emitters.	42
Theory of Oxide Emission—Activation of Oxide Emitters—Specific Emission Characteristics—Transient Emission	
4.5 Schottky Effect	46
4.6 Contact Difference of Potential.	48

	PAGE
4.7 Secondary Emission	48
Variation of Secondary Emission with Primary-electron Potential— Velocity Distribution of Secondary Electrons—Variation of Secondary Emission of Composite Layers—Secondary Emission of Insulators	
CHAPTER 5—DETERMINATION OF POTENTIAL FIELDS	58
5.1 Units and Dimensions	58
5.2 Fundamental Quantities and Definitions	59
Forces between Charges	
5.3 Solution of Potential Fields by Summation of Intensities	61
5.4 Summation of Potentials	62
5.5 Gauss's Law	64
5.6 Poisson's and Laplace's Equations	67
Interpretations of Laplace's Equation—Solutions of Laplace's Equa- tion in Two Dimensions—Difference Form of Laplace's Equation	
5.7 Elastic-membrane Models of Potential	75
5.8 Current-flow Models of Potential	76
5.9 Sketching of Flux and Potential Fields	80
Properties Useful in Sketching Fields	
5.10 Method of Conformal Transformations	82
Complex Functions Satisfy Laplace's Equation—Definition of Analytic Functions—The Logarithmic Transformation—The Function $W = Z^{1/n}$	
CHAPTER 6—LAWS OF ELECTRON MOTION	97
6.1 Electron in a Uniform Electric Field	97
6.2 Initial Velocity not Parallel to Field	99
6.3 Electrostatic Deflection of Cathode-ray Beams	101
6.4 Relativity Correction for Velocity	103
6.5 Two-dimensional Electric Fields	107
6.6 Electron in a Uniform Magnetic Field	111
6.7 Behavior of Electrons in Nonuniform Magnetic Fields	114
6.8 Combined Electric and Magnetic Fields	116
6.9 Approximate Numerical and Graphical Methods for Determining Elec- tron Paths	121
Method of Joined Circular Segments—Use of Elastic-membrane Model of Potential to Determine Electron Paths—Application of the Principle of Least Action	
CHAPTER 7—THE ELECTROSTATIC FIELD OF A TRIODE	125
7.1 Method of Solution	125
7.2 Electrostatic Field of a Plane-electrode Low- μ Triode	125
Contour Representation of Potential Field—Profile Representation of Potential Field	
7.3 Electrostatic Field of a Low- μ Cylindrical-electrode Triode	135
Potential Contours of a Cylindrical Triode—Potential Profiles of a Cylindrical Triode	
7.4 Analysis of the High- μ Triode	142
Potential Contours and Profiles—Amplification Factor of a High- μ Plane-electrode Triode—Amplification Factor of a High- μ Cylin- driical Triode	

	PAGE
7.5 The Equivalent Electrostatic Circuit of a Triode	152
7.6 Equivalent-diode Spacing of a Triode	153
Diode Equivalent to a Plane-electrode Triode—Diode Equivalent to a Cylindrical-electrode Triode	
7.7 Application of Amplification-factor Formulas to Actual Triodes	156
7.8 More Accurate Amplification-factor Formulas	158
Formula for Small Grid-plate Spacings—Formulas for Small Screening Fraction—Formula for Small Cathode-grid Spacings	
7.9 Amplification Factor of Unconventional Tubes	165
CHAPTER 8—SPACE-CHARGE EFFECTS	168
8.1 Effects of Current Flow	168
8.2 Plane-electrode Space-charge Flow	170
8.3 Cylindrical-electrode Space-charge Flow	173
8.4 Space-charge Flow for Other Geometries	181
Spherical Electrodes—The General Case	
8.5 Current Law for Plane Triodes	183
Current Law in Terms of Electrode Dimensions	
8.6 Mutual Conductance of a Plane Triode	188
8.7 Mutual Conductance of a Cylindrical Triode	188
8.8 Effect of Filamentary Emitters	189
8.9 Effect of Initial Electron Velocity	191
8.10 Effect of Space Charge upon Transit Time in Diodes	195
8.11 Summary	198
CHAPTER 9—TRIODE CHARACTERISTICS	201
9.1 Control Action of the Grid	201
9.2 Current-voltage Characteristics of the Triode	202
Plate-current-Grid-voltage Characteristics—Plate-current-Plate-voltage Characteristics—Contours of Constant Plate Current—The Plate-current Surface	
9.3 Definition of Triode Constants	205
Amplification Factor—Mutual Conductance—Plate Resistance—Relation between Tube Constants—Variation of Tube "Constants"	
9.4 Effective Tube Constants of Combinations of Tubes	212
9.5 Electron Paths	213
9.6 Grid Current	218
Grid-current-Grid-voltage Characteristics—Grid-current-Plate-voltage Characteristics—Constant-grid-current Contours—The Grid-current Surface—Effect of Secondary Electrons	
9.7 Primary-grid-current Law	224
Current-division Factor—Approximate Primary-grid-current Law—Current-division-factor Formula—Current-division Law in the Presence of Secondary Emission	
CHAPTER 10—TETRODES	238
10.1 Types of Tetrode	238
10.2 Current-voltage Characteristics of the Screen-grid Tube	238
Plate-current-Plate-voltage Characteristics of Screen-grid Tube—Screen-current-Plate-voltage Characteristics of the Screen-grid Tube—General Characteristics of Screen-grid Tubes	

	PAGE
10.3	Beam-power Tubes. 245
10.4	The Electrostatic Field of a Beam-power Tube. 245
10.5	Space-charge Effects in the Screen-grid-Anode Region of Beam-power Tubes. 248
	Type <i>A</i> Distribution—Type <i>B</i> Distribution—Type <i>C</i> Distribution— Type <i>D</i> Distributions
10.6	Dynamic Characteristics of Beam-power Tubes. 259
	Injected Current Varied, Potentials Constant—Plate Potential Varied, Screen Potential and Injected Current Constant
CHAPTER 11—PENTODES	266
11.1	Electrode Arrangement in a Pentode 266
11.2	Current-voltage Characteristics of the Pentode. 267
	Plate-current—Control-grid-voltage Characteristics—Plate-current— Plate-voltage Characteristics of a Pentode—Space-current—Plate-vol- tage Characteristics of the Pentode—Screen-grid-current—Plate-voltage Characteristics of a Pentode—Suppressor-grid Effects
11.3	Current Division in Pentodes 272
11.4	Amplification Factor of a Pentode 278
	Electrostatic Field of a Pentode—Electrostatic Amplification Factor of a Pentode—True Amplification Factor of a Pentode
11.5	Transconductance of a Pentode. 288
11.6	Plate Resistance of a Pentode 288
11.7	Design Considerations. 289
CHAPTER 12—NOISE IN VACUUM TUBES	298
12.1	Noise as a Limiting Factor in the Ultimate Sensitivity of Electronic Devices. 298
12.2	Noise in Resistors 299
12.3	Sources of Noise in Tubes. 305
12.4	Shot Noise in Diodes with Temperature-limited Emission 306
12.5	Reduced Shot Effect in Diodes with Space-charge-limited Emission. . . 308
12.6	Reduced Shot Effect in Triodes with Space-charge-limited Current . . 310
12.7	Noise Due to Gas in Tubes 312
12.8	Reduced Shot Effect in Multielectrode Tubes with Space-charge- limited Currents 313
12.9	Noise in Mixer Tubes. 314
12.10	Noise Induced at Ultra-high Frequencies by Random Emission. . . . 316
12.11	Noise in Velocity-modulation Tubes. 317
12.12	Noise in Phototubes 318
12.13	Noise in Secondary-emission Multipliers. 319
12.14	Definition of Noise Figure. 321
	Noise Figure for Two Networks in Cascade
12.15	Measurement of Noise and Noise Figure 325
	Typical Tube-noise Values
CHAPTER 13—ELECTROSTATIC ELECTRON OPTICS	328
13.1	Introduction. 328
	Snell's Law—The Principle of Least Action—Simple Lenses—Lens Formulas

	PAGE
13.2 Electrostatic-lens Fields	337
General Form of Fields with Rotational Symmetry—The Equal-diameter Two-cylinder Lens—Equal-diameter Spaced Cylinders—Two-diameter Cylinder Lenses—Aperture Lenses	
13.3 Electron Paths	349
13.4 General Lens Properties	350
Thin Lenses—Thick Lenses	
13.5 Calculation of Lens Characteristics	360
Method of Linear Axial-potential Segments—Method of Equivalent Thin Lenses	
13.6 Measurement of Lens Characteristics	365
Double-grid Method of Measuring Lens Characteristics	
13.7 Optical Characteristics of Lenses	369
13.8 Calculation of Lens Characteristics	375
13.9 <i>P-Q</i> Curves of Lenses	377
Comparison of Lenses—The <i>Einzel</i> Lens	
13.10 Aberrations	387
Chromatic Aberration—Coma—Astigmatism—Curvature of Field—Distortion of Field—Spherical Aberration—Other Lens Defects	
CHAPTER 14—MAGNETIC LENSES	394
14.1 Focusing Action of Axial Magnetic Fields	394
14.2 Magnetic Fields with Rotational Symmetry	396
14.3 Electron Motion in a Magnetic Field Expressed in Cylindrical Coordinates	397
14.4 Differential Equations of Motion of the Paraxial Electron	398
14.5 Focusing Properties of Magnetic Lenses	399
General—Magnetic Lens of a Circular Turn of Wire—The Glazer Lens	
14.6 Practical Magnetic Lenses	404
14.7 Magnetic-lens Defects	405
14.8 The General Equations of Motion in Combined Electric and Magnetic Fields	406
CHAPTER 15—CATHODE-RAY TUBES	412
15.1 The General Form of Cathode-ray Tubes	412
15.2 Electron-gun Design	414
Cutoff Relations in the Electron Gun—Electron Paths in the Electron Gun—Focusing System—Alternative Electrode Structures	
15.3 Deflection Devices	425
Electrostatic Deflecting Plates—Magnetic Deflection—Relative Merits of Electrostatic and Magnetic Deflection—Visual versus Deflection Sensitivity—Postdeflection Acceleration	
15.4 Fluorescent Materials	429
Definitions—General Make-up of Phosphors—Luminous Properties of Fluorescent Materials—Electrical Characteristics of Phosphors	
15.5 Limitations of Spot Size	437
Effect of Thermal Velocity of Emission—Space-charge Limitation of Spot Size—Effect of Secondary Emission—Halation	

	PAGE
15.6 High-efficiency Cathodes	449
Parallel Flow of a Rectangular Beam—Parallel-flow Cylindrical Beam—Convergent Radial Flow of a Conical Beam	
15.7 Ultra-high-frequency Deflection Effects	465
15.8 Photography of Cathode-ray Traces	470
Beam Power—Screen Types—Writing Speed—Time, Stop, and Mag- nification—Film Sensitivity—Developers and Development	
CHAPTER 16—ULTRA-HIGH-FREQUENCY EFFECTS IN CONVENTIONAL TUBES	475
16.1 Introduction	475
16.2 Causes of Decreased Output at Ultra-high Frequencies	475
16.3 Onset of Tube-reactance Limitations	477
16.4 The Nature of Currents Induced by Electron Motion at Ultra-high Frequencies	482
The General Case—The Diode without Space Charge—The Diode with Space Charge—Currents Induced in the Electrodes of a Triode	
16.5 Onset of Transit-time Effects in Triodes	490
16.6 Transit-time Effects in the Space-charge-limited Diode	495
16.7 Small-signal Transit-time Effects in the Space-charge-limited Triode	501
16.8 Similitude and Scaling in Ultra-high-frequency Triodes	504
16.9 High-frequency Limit of Triode Oscillation	507
16.10 Large-signal Effects	516
Transit-time Effects in Diodes—Transit-time Effects in Triodes— Transit-time Effects in Tetrodes—The Resnatron	
16.11 Disk-seal Tubes	524
CHAPTER 17—VELOCITY-MODULATED TUBES OR KLYSTRONS	527
17.1 The Bunching Principle	527
17.2 Cavity Resonators	529
17.3 Mechanism of Energy Interchange between Electrons and Cavity Resonators	537
17.4 First-order Bunching Theory	541
17.5 The Klystron Amplifier	556
Structure of the Klystron Amplifier—Output Power of the Klystron Amplifier—Efficiency of the Klystron Amplifier—Mutual Conductance of the Klystron Amplifier—Power Required to Bunch the Beam	
17.6 The Cascade Amplifier	564
17.7 Frequency-multiplier Klystrons	566
17.8 Second-order Bunching Effects	567
17.9 The Reflex-klystron Oscillator	571
Behavior of Electrons in the Reflector Space—Distance-time Diagram of a Reflex-klystron Oscillator—Bunching Theory of the Reflex-klystron Oscillator—Self-admittance of the Beam—Mechanism by Which Oscillations Start—Variation of Beam Conductance with Amplitude of Oscillation—The Electronic-admittance Spiral—Reflex-klystron Os- cillation with a Simple Resonant Circuit—Power Relations in the Reflex-klystron Oscillator—Voltage Stability of Reflex-klystron Oscillators	
17.10 Broad-band Operation of Reflex-klystron Oscillators	591
Equivalent Circuit of Concentric-line Resonator—Possible Modes of	

Oscillation—Method of Calculating Oscillation Mode Plot—Mode Interference

17.11	The Two-resonator Klystron Oscillator	606
17.12	The Heil Tube.	616
17.13	Bunching Effects in Negative-grid Tubes	616

CHAPTER 18—MAGNETRON OSCILLATORS 621

18.1	Introduction.	621
18.2	Structural Form of Magnetrons	622
18.3	Resonant Properties of Multicavity Magnetrons	625
18.4	Electron Behavior in Crossed Static Magnetic and Static Electric Fields: Plane Case	631
18.5	Electron Behavior in Crossed Magnetic and Alternating Electric Fields: Plane Case.	636
	Alternating Transverse Electric-field Effect of a Traveling Electric Field	
18.6	Electron Behavior in Crossed Magnetic and Radial Electric Fields	642
18.7	The Effect of Space Charge	648
18.8	Electron Behavior in Crossed Magnetic and Alternating Radial Electric Fields.	651
18.9	Basic Design Relations for Multicavity Magnetrons.	660
18.10	Dimensional Relations in Magnetrons.	665
18.11	Output Characteristics of Magnetrons.	667

CHAPTER 19—PHOTOELECTRIC TUBES. 675

19.1	The General Form of Photoelectric Tubes.	675
19.2	Fundamental Photoelectric Relations	675
19.3	History of the Photoelectric Effect	676
19.4	Specific Photoemission Characteristics.	677
19.5	Fundamental Theory of Photoemission	681
19.6	Spectral Response Curves of Photoemissive Surfaces	683
19.7	Vacuum-phototube Characteristics	684
	Current-voltage Characteristics—Spectral Characteristics	
19.8	Gas-phototube Characteristics	688
	Factors in the Design of Gas Phototubes—Frequency Distortion in Gas Phototubes—Summary of Gas-phototube Characteristics	
19.9	Utilization of Phototube Characteristics.	693
19.10	Photomultiplier Tubes	694

CHAPTER 20—SPECIAL TUBES 701

20.1	Introduction.	701
20.2	The Hexode	702
20.3	The Heptode.	710
20.4	The Pentagrid Converter	714
20.5	The Octode	716
20.6	Space-charge Grid Tubes	717
20.7	Negative-resistance Tubes.	718
	Glow-discharge Tubes—The Dynatron—Direct-coupled Negative-resistance Devices—Negative Screen-grid Resistance of a Pentode—	

	PAGE
Push-pull Negative-resistance Circuit—Feedback Circuits—Special Negative-resistance Tubes	
20.8 Negative-transconductance Tubes	723
20.9 Electron-ray Indicator Tubes	723
20.10 Directed-ray Electron Tubes	724
20.11 Deflection Tubes	727
20.12 Television Camera Tubes	728
The Image-dissector Tube—The Iconoscope—The Image Iconoscope—The Orthicon—The Image Orthicon—The Monoscope	
20.13 The Electron Microscope	738
Structure of the Electron Microscope—Equivalent Wave Length of Electrons—Theoretical Resolving Power of the Electron Microscope—Operating Principle of the Electron Microscope—Limits of Resolving Power—Electrostatic Electron Microscopes	
CHAPTER 21—HIGH-VACUUM PRACTICE	747
21.1 Introduction	747
21.2 Fundamental Gas Laws	749
Boyle's Law—Charles's Law or Gay-Lussac's Law—Avogadro's Law—General Gas-expansion Law—Distribution of Velocities in a Gas—Mean Free Path of a Gas Molecule—Mean Free Path of an Electron among Gas Molecules	
21.3 Measurement of Vacuum	757
Manometers—The McLeod Gauge—The Spark-discharge Tube—The Pirani Gauge—The Thermocouple Gauge—Triode Ionization Gauge	
21.4 Pumping Speed	775
Speed of an Aperture—Definition of Pump Speed—Speed of Tubing—Effect of Tubing Upon Pumping Speed	
21.5 Production of Low Vacuum	780
21.6 Production of High Vacuum	781
The Mercury-diffusion Pump—Oil Pumps—Fractionating Pumps	
21.7 Glass and Its Properties	791
Composition of Glass—Physical Properties of Glass—Working of Glass	
21.8 Sealing of Glass to Other Materials	796
Sealing of Small Leads Into Glass—Copper-to-glass Seals—Kovar and Fernico—Glass-to-porcelain Seals—Glass-to-mica Seals	
21.9 Metals Useful in Tube Construction	801
Nickel—Copper—Aluminum—Molybdenum—Tantalum—Tungsten—Relative Properties of the Metals—Spot Welding	
21.10 Insulators	807
21.11 Degassing of Glass and Metals	808
21.12 Getters	809

APPENDICES

I. Properties of the Elements	811
II. Differential Operators and Vector Notation	813
III. A Note on Mks Units	817
IV. Characteristics of Fluorescent Screens	821

CONTENTS

xvii

PAGE

V. Surface Resistance and Depth of Penetration of Current Resulting from Skin Effects	822
VI. Principal Properties of the Bessel Functions	823
VII. Values of α^2 as a Function of r_c/r for use in Eq. (15.63).	825
VIII. Nomographic Chart Relating Object and Image Distance to the Focal Length of a Thin Lens	826
IX. Nomographic Chart Relating Tube Constants.	827
X. Designation of Frequency Bands.	828
PROBLEMS	829
NAME INDEX.	849
SUBJECT INDEX.	853